



ITW

Docket No.: 8733.913.00
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
KIM, Sang-Hyun

Application No.: 10/663,805

Confirmation No.: 3765

Filed: September 17, 2003

Art Unit: 1765

For: FABRICATION METHOD OF
POLYCRYSTALLINE SILICON TFT

Examiner: Unknown

STATUS INQUIRY


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: December 2, 2004

Respectfully submitted,

By 
Rebecca Goldman Rudich
Registration No.: 41,786

MCKENNA LONG & ALDRIDGE LLP
1900 K Street, N.W.
Washington, DC 20006
(202) 496-7500
Attorneys for Applicant